

81/04

655 Montgomery Street, Suite 1800. San Francisco, Ca 94111.
tel 415.318.1160. fax 415.693.0194

Applicant(s): Wayne G. Renken

Title: Process Condition Sensing Wafer and Data Analysis System

Application No.: 10/056,906

Filing Date: January 24, 2002

Examiner: Charles D. Garber

Group Art Unit: 2856

Docket No.: SENS.005US0

Conf. No.: 2359

Mail Stop Amendment
Commissioner For Patents
P.O. Box 1450
Alexandria, VA 22313-1450

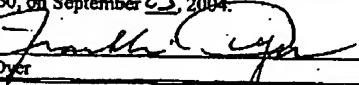
Dear Sir:

Transmitted herewith are the following documents in the above-identified application:

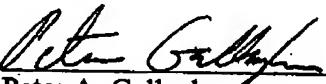
- (1) Amendment (12 pages); and
- (2) Return Postcard.

Certificate of Mailing Under 37 CFR 1.8

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on September 23, 2004.


Franklin Dyer

Respectfully submitted,


Peter A. Gallagher
Reg. No. 47,584

9/23/04
Date

34/34

Auto-Reply Facsimile Transmission



TO: Fax Sender at 4156930196

Fax Information
 Date Received: 6/17/2005 2:26:13 PM [Eastern Daylight Time]
 Total Pages: 2 (Including cover page)

ADVISORY: This is an automatically generated return receipt confirmation of the facsimile transmission received by the Office. Please check to make sure that the number of pages listed as received in Total Pages above matches what was intended to be sent. Applicants are advised to retain this receipt in the unlikely event that proof of this facsimile transmission is necessary. Applicants are also advised to use the certificate of facsimile transmission procedures set forth in 37 CFR 1.8(a) and (b); 37 CFR 1.6(f). Trademark Applicants, also see the Trademark Manual of Examining Procedure (TMEP) section 306 et seq.

Received
 Cover
 Page
 =====>

17-Jun-2005 11:26am	From-PARSONS HSUE & DE RUNTZ LLP	4156930194	T-694	P.034/036	F-135
PARSONS HSUE & DE RUNTZ LLP <hr/> <p>655 Montgomery Street, Ninth Floor San Francisco, CA 94111 tel 415.315.1160 fax 415.583.0194</p> <hr/> <p>Date <i>June 17, 2005</i> To United States Patent and Trademark Office Fax number 703-672-0306 Tel number (800) 786-9199</p> <hr/> <p>From Peter Gallagher, Reg. No. 17,594 Total pages 2 Subject Status Request Our Ref. SENS.005US1</p> <hr/> <p>COMMISSIONER FOR PATENTS P.O. BOX 1458 ALEXANDRIA, VA 22313-1458 Application: Wayne G. Rankra Title: Process Condition Sensing Wafer and Data Analysis System Application No.: 10/693,450 Filing Date: October 14, 2003 Cont. No.: 4924 Any Docket No.: SENS.005US1 ENCLOSED: 1. Request for Status - 1 page PAG/sep Due Date: n/a</p> <hr/> <p><small>This facsimile is sent by a law firm and may contain information that is confidential or privileged if you are not the intended recipient, please notify us immediately and return this facsimile and any documents to us by mail.</small></p> <p><small>PAGE 34/36 RCVD AT 07/15/2005 2:26:13 PM [Eastern Daylight Time] * SVR:USPTO-EFXRF-1/25 * DNI:2738300 * CSID:4156930194 * DURATION (mm:ss):13-02</small></p>					

~~PARSONS HSUE & DE RUNTZ~~

655 Montgomery Street, Suite 1800 San Francisco, Ca 94111
tel 415.318.1160 fax 415.693.0194

Date June 17, 2005
To United States Patent and Trademark Office
Fax number 703-872-9306
Tel number (800) 786-9199

From Peter Gallagher, Reg. No. 47,584
Total pages 2
Subject Status Request
Our Ref. SENS.005US1

COMMISSIONER FOR PATENTS

P.O. BOX 1450
ALEXANDRIA, VA 22313-1450

Applicants: Wayne G. Renken
Title: Process Condition Sensing Wafer and Data Analysis System
Application No.: 10/685,550
Filing Date: October 14,2003
Conf. No.: 4924
Atty Docket No.: SENS.005US1

ENCLOSED:

1. Request for Status – 1 page

PAC/aep

Due Date: n/a

THIS FAXSIMILE IS SENT BY A LAW FIRM AND MAY CONTAIN INFORMATION THAT IS CONFIDENTIAL OR PRIVILEGED If you are not the intended recipient, please notify us immediately and return this facsimile and any attachments to us by mail.

3636
1 RECEIVED
CENTRAL FAX CENTERIN THE UNITED STATES PATENT AND TRADEMARK OFFICE

JUL 15 2005

Applicant: Wayne G. Renken
Title: Process Condition Sensing Wafer and Data Analysis System
Application No.: 10/685,550 Filing Date: October 14, 2002
Examiner: Charles D. Garber Group Art Unit: 2856
Docket No.: SENS.005US1 Conf. No.: 4924

Certificate of Transmission Under 37 CFR 1.8

I hereby certify that this correspondence is being facsimile transmitted to the United States Patent and Trademark Office on June 16, 2005.

Ann-Ellice Parker
Ann-Ellice Parker

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

REQUEST FOR STATUS OF APPLICATION

Sir:

Applicant filed a Response to a Notice of Abandonment on February 16, 2005. Applicant hereby requests a report on the status of the above-identified patent application. If a telephone call would expedite this request, please call the Attorney of Record, shown below.

Respectfully submitted,

Peter Gallagher
Peter A. Gallagher
Reg. No. 47,584

Date

6/16/05

PARSONS HSUE & DE RUNTZ LLP
655 Montgomery Street, Suite 1800
San Francisco, CA 94111
(415) 318-1160 (main)
(415) 318-1167 (direct)
(415) 693-0194 (fax)